

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		09836449	
	Filing Date		2001-04-17	
	First Named Inventor	Stephen J. Fonash		
	Art Unit	2812		
	Examiner Name	Richard A. Booth		
Attorney Docket Number		201009-007000		

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1	BAE ET AL., "Characteristics of amorphous and polycrystalline silicon films deposited at 120 C by electron cyclotron resonance-enhanced chemical vapor deposition," J. Vac. Sci. & Technol. A16(3), May/June 1998, pp. 1912-1916.	<input type="checkbox"/>
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☐ That each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement. See 37 CFR 1.97(e)(1).

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- ☐ See attached certification statement.
- ☐ Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.
- ☒ None

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A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/Stephen M. Hertzler, Reg. No. 58247/	Date (YYYY-MM-DD)	2007-04-26
Name/Print	Stephen M. Hertzler	Registration Number	58247

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